NOTICE OF REVISION (NOR) 1. DATE (YYMMDD) 97-12-09				Form Approved OMB No. 0704-0188	
THIS REVISION DESCRIBED BELOW HAS BEEN AUTHORIZED FOR THE DOCUMENT LISTED.					
Public reporting burden for this collection is estimated to average 2 hours per response, including the time for reviewing instructions, searching existing data sources, gathering and maintaining the data needed, and completing and reviewing the collection of information. Send comments regarding this burden estimate or any other aspect of this collection of information, including suggestions for reducing this burden, to Department of Defense, Washington Headquarters Services, Directorate for Information Operations and Reports, 1215 Jefferson Davis Highway, Suite 1204, Arlington, VA 22202-4302, and to the Office of Management and Budget, Paperwork Reduction Project (0704-0188), Washington, DC 20503. PLEASE DO NOT RETURN YOUR COMPLETED FORM TO EITHER OF THESE ADDRESSED. RETURN COMPLETED FORM TO THE GOVERNMENT ISSUING CONTRACTING OFFICER FOR THE CONTRACT/ PROCURING ACTIVITY NUMBER LISTED IN ITEM 2 OF THIS FORM.					2. PROCURING ACTIVITY NO.
					3. DODAAC
4. ORIGINATOR				5. CAGE CODE 67268	6. NOR NO. 5962-R009-98
a. TYPED NAME (First, Middle Initial, Last)				7. CAGE CODE 67268	8. DOCUMENT NO. 5962-96601
9. TITLE OF DOCUMENT MICROCIRCUIT, DIGITAL, RADIATION BIDIRECTIONAL UNIVERSAL SHIFT F			10. REVISION LETT	ER	11. ECP NO. No users listed.
			a. CURRENT	b. NEW A	
12. CONFIGURATION ITEM (OR SYS	TEM) TO WHICH ECF	PAPPLIES			
13. DESCRIPTION OF REVISION					
Sheet 1: Revisions Itr column; add "A". Revisions description column; add "Changes in accordance with NOR 5962-R009-98". Revisions date column; add "97-12-09". Revision level block; add "A". Rev status of sheets; for sheets 1, 4, and 15 through 23, add "A".					
Sheet 4: Add new paragraph which s this document." Revision level block; add "A		rcuit die. For the requ	irements for microcircu	iit die, see appendix A t	0
Sheets 15 through 23: Add attached	appendix A.				
CONTINUED ON NEXT SH	HEETS				
14. THIS SECTION FOR GOVER	NMENT USE ONL	Y			
a. (X one) X (1) Existing	document supplem	ented by the NOR	may be used in mar	ufacture.	
(2) Revised	document must be	received before ma	anufacturer may inc	orporate this change	
(3) Custodia	an of master docum	ent shall make abo	ve revision and furn	ish revised documer	nt.
b. ACTIVITY AUTHORIZED TO A GOVERNMENT	PPROVE CHANGE	FOR	c. TYPED NAME	(First, Middle Initial,	Last)
DSCC-VAC			MONICA L. POE	ELKING	
d. TITLE e. SIGNATURE f.			f. DATE SIGNED		
CHIEF, CUSTOM MICROELECTRONICS TEAM MONICA L. POELKING			(YYMMDD) 97-12-09		
15a. ACTIVITY ACCOMPLISHING REVISION b. REVISION COMPLETED (Signature)				c. DATE SIGNED	
DSCC-VAC CHARLES F. SAFFLE, JR.			(<i>YYMMDD</i>) 97-12-09		

Document No: 5962-96601

Revision: A

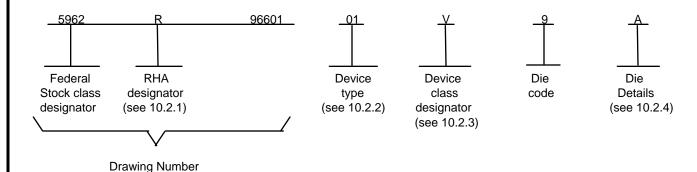
NOR No: 5962-R009-98

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10. SCOPE

10.1 <u>Scope</u>. This appendix establishes minimum requirements for microcircuit die to be supplied under the Qualified Manufacturers List (QML) Program. QML microcircuit die meeting the requirements of MIL-PRF-38535 and the manufacturers approved QM plan for use in monolithic microcircuits, multichip modules (MCMs), hybrids, electronic modules, or devices using chip and wire designs in accordance with MIL-PRF-38534 are specified herein. Two product assurance classes consisting of military high reliability (device class Q) and space application (device Class V) are reflected in the Part or Identification Number (PIN). When available a choice of Radiation Hardiness Assurance (RHA) levels are reflected in the PIN.

10.2 PIN. The PIN shall be as shown in the following example:



10.2.1 RHA designator. Device classes Q and V RHA identified die shall meet the MIL-PRF-38535 specified RHA levels. A dash (-) indicates a non-RHA die.

10.2.2 Device type(s). The device type(s) shall identify the circuit function as follows:

Device type	Generic number	Circuit function
01	40104B	Radiation Hardened, CMOS, 4-bit bidirectional universal shift register, with 3-state outputs.
02	40194B	Radiation Hardened, CMOS, 4-bit bidirecti <u>onal uni</u> versal shift register, with RESET.

10.2.3 Device class designator.

<u>Device class</u> <u>Device requirements documentation</u>

Q or V Certification and qualification to the die requirements of MIL-PRF-38535.

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10.2.4 <u>Die Details</u>. The die details designation shall be a unique letter which designates the die's physical dimensions, bonding pad location(s) and related electrical function(s), interface materials, and other assembly related information, for each product and variant supplied to this appendix.

10.2.4.1 Die Physical dimensions.

<u>Die Types</u>	<u>Figure number</u>
01	A-1
02	A-2

10.2.4.2 Die Bonding pad locations and Electrical functions.

Die Types	Figure number
01	A-1
02	A-2

10.2.4.3 Interface Materials.

<u>Die Types</u>	Figure number
01 02	A-1 A-2
10.2.4.4 <u>Assembly related information</u> .	

- 01 A-1 02 A-2
- 10.4 Recommended operating conditions. See paragraph 1.4 within the body of this drawing for details.

10.3 Absolute maximum ratings. See paragraph 1.3 within the body of this drawing for details.

- 20. APPLICABLE DOCUMENTS
- 20.1 <u>Government specifications, standards, bulletin, and handbooks</u>. Unless otherwise specified, the following specifications, standards, bulletin, and handbook of the issue listed in that issue of the Department of Defense Index of Specifications and Standards specified in the solicitation, form a part of this drawing to the extent specified herein.

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SPECIFICATION

DEPARTMENT OF DEFENSE

MIL-PRF-38535 - Integrated Circuits, Manufacturing, General Specification for.

STANDARDS

DEPARTMENT OF DEFENSE

MIL-STD-883 - Test Methods and Procedures for Microelectronics.

HANDBOOK

DEPARTMENT OF DEFENSE

MIL-HDBK-103 - List of Standardized Military Drawings (SMD's).

(Copies of the specification, standards, bulletin, and handbook required by manufacturers in connection with specific acquisition functions should be obtained from the contracting activity or as directed by the contracting activity).

20.2 Order of precedence. In the event of a conflict between the text of this drawing and the references cited herein, the text of this drawing shall take precedence.

30. REQUIREMENTS

- 30.1 <u>Item Requirements</u>. The individual item requirements for device classes Q and V shall be in accordance with MIL-PRF-38535 and as specified herein or as modified in the device manufacturer's Quality Management (QM) plan. The modification in the QM plan shall not effect the form, fit or function as described herein.
- 30.2 <u>Design, construction and physical dimensions</u>. The design, construction and physical dimensions shall be as specified in MIL-PRF-38535 and the manufacturer's QM plan, for device classes Q and V and herein.
 - 30.2.1 <u>Die Physical dimensions</u>. The die physical dimensions shall be as specified in 10.2.4.1 and on figures A-1 and A-2.
- 30.2.2 <u>Die bonding pad locations and electrical functions</u>. The die bonding pad locations and electrical functions shall be as specified in 10.2.4.2 and on figures A-1 and A-2.
 - 30.2.3 Interface materials. The interface materials for the die shall be as specified in 10.2.4.3. and on figures A-1 and A-2.
- 30.2.4 <u>Assembly related information</u>. The assembly related information shall be as specified in 10.2.4.4. and figures A-1 and A-2.
 - 30.2.5 Truth Tables. The truth tables shall be as defined within paragraph 3.2.3 of the body of this document.

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30.2.6 Radiation exposure circuit. The radiation exposure circuit shall be as defined within paragraph 3.2.4. of the body of this document.

- 30.3 <u>Electrical performance characteristics and post-irradiation parameter limits</u>. Unless otherwise specified herein, the electrical performance characteristics and post-irradiation parameter limits are as specified in table I of the body of this document.
- 30.4 <u>Electrical test requirements</u>. The wafer probe test requirements shall include functional and parametric testing sufficient to make the packaged die capable of meeting the electrical performance requirements in table I.
- 30.5 <u>Marking</u>. As a minimum, each unique lot of die, loaded in single or multiple stack of carriers, for shipment to a customer, shall be identified with the wafer lot number, the certification mark, the manufacturer's identification and the PIN listed in 10.2 herein. The certification mark shall be a "QML" or "Q" as required by MIL-PRF-38535.
- 30.6 <u>Certification of compliance</u>. For device classes Q and V, a certificate of compliance shall be required from a QML-38535 listed manufacturer in order to supply to the requirements of this drawing (see 60.4 herein). The certificate of compliance submitted to DSCC-VA prior to listing as an approved source of supply for this appendix shall affirm that the manufacturer's product meets, for device classes Q and V, the requirements of MIL-PRF-38535 and the requirements herein.
- 30.7 <u>Certificate of conformance</u>. A certificate of conformance as required for device classes Q and V in MIL-PRF-38535 shall be provided with each lot of microcircuit die delivered to this drawing.
 - 40. QUALITY ASSURANCE PROVISIONS
- 40.1 <u>Sampling and inspection</u>. For device classes Q and V, die sampling and inspection procedures shall be in accordance with MIL-PRF-38535 or as modified in the device manufacturer's Quality Management (QM) plan. The modifications in the QM plan shall not effect the form, fit or function as described herein.
- 40.2 <u>Screening</u>. For device classes Q and V, screening shall be in accordance with MIL-PRF-38535, and as defined in the manufacturer's QM plan. As a minimum it shall consist of:
 - a) Wafer Lot acceptance for Class V product using the criteria defined within MIL-STD-883 TM 5007.
 - b) 100% wafer probe (see paragraph 30.4).
 - c) 100% internal visual inspection to the applicable class Q or V criteria defined within MIL-STD-883 TM2010 or the alternate procedures allowed within MIL-STD-883 TM5004.

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40.3 Conformance inspection.

40.3.1 <u>Group E inspection</u>. Group E inspection is required only for parts intended to be identified as radiation assured (see 30.5 herein). RHA levels for device classes Q and V shall be as specified in MIL-PRF-38535. End point electrical testing of packaged die shall be as specified in table IIA herein. Group E tests and conditions are as specified within paragraphs 4.4.4.1, 4.4.4.2, 4.4.4.3 and 4.4.4.4.

50. DIE CARRIER

50.1 <u>Die carrier requirements</u>. The requirements for the die carrier shall be accordance with the manufacturer's QM plan or as specified in the purchase order by the acquiring activity. The die carrier shall provide adequate physical, mechanical and electrostatic protection.

60. NOTES

- 60.1 <u>Intended use</u>. Microcircuit die conforming to this drawing are intended for use in microcircuits built in accordance with MIL-PRF-38535 or MIL-PRF-38534 for government microcircuit applications (original equipment), design applications and logistics purposes.
- 60.2 <u>Comments</u>. Comments on this appendix should be directed to DSCC-VA, Columbus, Ohio, 43216-5000 or telephone (614)-692-0536.
- 60.3 <u>Abbreviations, symbols and definitions</u>. The abbreviations, symbols, and definitions used herein are defined with MIL-PRF-38535 and MIL-STD-1331.
- 60.4 <u>Sources of Supply for device classes Q and V</u>. Sources of supply for device classes Q and V are listed in QML-38535. The vendors listed within QML-38535 have submitted a certificate of compliance (see 30.6 herein) to DSCC-VA and have agreed to this drawing.

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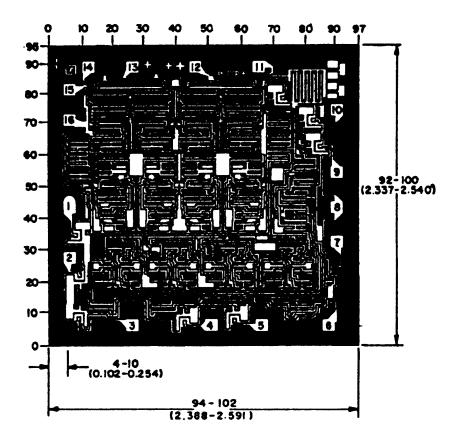
Sheet: 7 of 10

FIGURE A-1

o DIE PHYSICAL DIMENSIONS

Die Size: 2413 x 2464 microns. Die Thickness: 20 +/-1 mils.

o DIE BONDING PAD LOCATIONS AND ELECTRICAL FUNCTIONS



NOTE: Pad numbers reflect terminal numbers when placed in Case Outlines E, X (see Figure 1).

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o INTERFACE MATERIALS

Top Metallization: Al 11.0kA - 14.0kA

Backside Metallization None

Glassivation

Type: PSG

Thickness 10.4kA - 15.6kA

Substrate: Single crystal silicon

o ASSEMBLY RELATED INFORMATION

Substrate Potential: Floating or tied to VDD.

Special assembly

instructions: Bond pad #16 (VDD) first.

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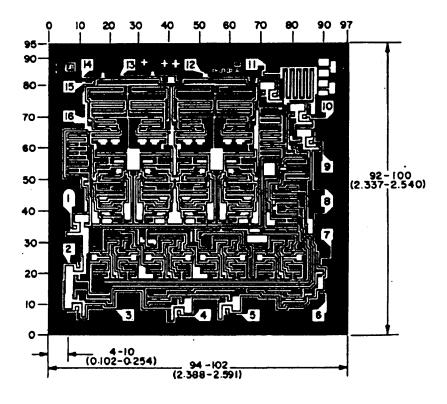
FIGURE A-2

o DIE PHYSICAL DIMENSIONS

Die Size: 2413 x 2464 microns.

Die Thickness: 20 +/-1 mils.

o DIE BONDING PAD LOCATIONS AND ELECTRICAL FUNCTIONS



NOTE: Pad numbers reflect terminal numbers when placed in Case Outlines E, X (see Figure 1).

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o INTERFACE MATERIALS

Top Metallization: Al 11.0kA - 14.0kA

Backside Metallization None

Glassivation

Type: PSG

Thickness 10.4kA - 15.6kA

Substrate: Single crystal silicon

o ASSEMBLY RELATED INFORMATION

Substrate Potential: Floating or tied to VDD.

Special assembly

instructions: Bond pad #16 (VDD) first.

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STANDARD MICROCIRCUIT DRAWING BULLETIN

DATE: 97-12-09

Approved sources of supply for SMD 5962-96601 are listed below for immediate acquisition information only and shall be added to MIL-HDBK-103 and QML-38535 during the next revision. MIL-HDBK-103 and QML-38535 will be revised to include the addition or deletion of sources. The vendors listed below have agreed to this drawing and a certificate of compliance has been submitted to and accepted by DSCC-VA. This bulletin is superseded by the next dated revision of MIL-HDBK-103 and QML-38535.

Standard microcircuit drawing PIN	Vendor CAGE number	Vendor similar PIN <u>1</u> /
5962R9660101V9A	34371	CD40104BHSR
5962R9660102V9A	34371	CD40194BHSR

1/ Caution. Do not use this number for item acquisition. Items acquired to this number may not satisfy the performance requirements of this drawing.

Vendor CAGE number

Harris Semiconductor

34371 P.O. Box 883

Melbourne, FL 32902-0883

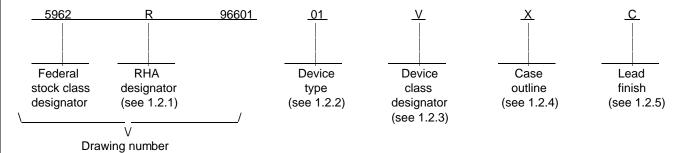
Vendor name and address

The information contained herein is disseminated for convenience only and the Government assumes no liability whatsoever for any inaccuracies in the information bulletin.

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AMSC N/A										SHEET 1 OF 14										

1. SCOPE

- 1.1 <u>Scope</u>. This drawing forms a part of a one part one part number documentation system (see 6.6 herein). Two product assurance classes consisting of military high reliability (device classes Q and M) and space application (device class V), and a choice of case outlines and lead finishes are available and are reflected in the Part or Identifying Number (PIN). Device class M microcircuits represent non-JAN class B microcircuits in accordance with 1.2.1 of MIL-STD-883, "Provisions for the use of MIL-STD-883 in conjunction with compliant non-JAN devices". When available, a choice of Radiation Hardness Assurance (RHA) levels are reflected in the PIN.
 - 1.2 PIN. The PIN shall be as shown in the following example:



- 1.2.1 RHA designator. Device class M RHA marked devices shall meet the MIL-I-38535 appendix A specified RHA levels and shall be marked with the appropriate RHA designator. Device classes Q and V RHA marked devices shall meet the MIL-I-38535 specified RHA levels and shall be marked with the appropriate RHA designator. A dash (-) indicates a non-RHA device.
 - 1.2.2 <u>Device type(s)</u>. The device type(s) shall identify the circuit function as follows:

Device type	Generic number	<u>Circuit function</u>
01	40104B	Radiation hardened CMOS 4-bit bidirectional
02	40194B	universal shift register, with 3-state outputs Radiation hardened CMOS <u>4-bit bi</u> directional
		universal shift register, with RESET

1.2.3 <u>Device class designator</u>. The device class designator shall be a single letter identifying the product assurance level as follows:

<u>Device class</u>	Device requirements documentation
М	Vendor self-certification to the requirements for non-JAN class B microcircuits in accordance with 1.2.1 of MIL-STD-883
Q or V	Certification and qualification to MIL-I-38535

1.2.4 Case outline(s). The case outline(s) shall be as designated in MIL-STD-1835 and as follows:

Outline letter	Descriptive designator	<u>Terminals</u>	Package style
E	CDIP2-T16	16	Dual-in-line package
X	CDFP4-F16	16	Flat package

1.2.5 <u>Lead finish</u>. The lead finish shall be as specified in MIL-STD-883 (see 3.1 herein) for class M or MIL-I-38535 for classes Q and V. Finish letter "X" shall not be marked on the microcircuit or its packaging. The "X" designation is for use in specifications when lead finishes A, B, and C are considered acceptable and interchangeable without preference.

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1.3 Absolute maximum ratings. 1/2/3/			
Supply voltage range (V _{DD}) Input voltage range DC input current, any one input Device dissipation per output transistor Storage temperature range (T _{STG}) Lead temperature (soldering, 10 seconds) Thermal resistance, junction-to-case (Θ _{JC}): Case E Case X Thermal resistance, junction-to-ambient Θ _{JA}): Case E Case X Junction temperature (T _J) Maximum power dissipation at T _A = +125°C (P _D): 4/ Case E Case X		±10 mA 100 mW 65° C to +150° C +265° C 24° C/W 29° C/W 73° C/W 114° C/W +175° C 0.68 W	dc - 0.5 Vdc
1.4 Recommended operating conditions.			
Supply voltage range (V _{DD})		1 x 10 ⁵ Rads (Si)	ı) 5/
Dose rate latch-up Dose rate survivability		> 5 x 10° Rads(Si > 2 x 10° Rads(Si > 5 x 10 ¹¹ Rads(Si)/s <u>5</u> /)/s <u>5</u> / Si)/s <u>5</u> /
2. APPLICABLE DOCUMENTS			
2.1 <u>Government specification, standards, bulletin, and handb</u> standards, bulletin, and handbook of the issue listed in that issu Standards specified in the solicitation, form a part of this drawing	e of the Departmer	nt of Defense Index of Spec	g specification, ifications and
SPECIFICATION			
MILITARY			
MIL-I-38535 - Integrated Circuits, Manufacturing, Gener	al Specification for		
STANDARDS			
MILITARY			
MIL-STD-883 - Test Methods and Procedures for Micro MIL-STD-973 - Configuration Management. MIL-STD-1835 - Microcircuit Case Outlines.	oelectronics.		
1/ Stresses above the absolute maximum rating may cause per maximum levels may degrade performance and affect reliab Unless otherwise specified, all voltages are referenced to V The limits for the parameters specified herein shall apply ov 55° C to +125° C unless otherwise noted. 4/ If device power exceeds package dissipation capability, probased on θ _{JA}) at the following rate: Case E	ility. SS: er the full specified vide heat sinking o	of V _{CC} range and case temper derate linearly (the deration 13.7 mW/°C	perature range of -
STANDARD MICROCIRCUIT DRAWING	SIZE A		5962-96601
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BULLETIN

MILITARY

MIL-BUL-103 - List of Standardized Military Drawings (SMD's).

HANDBOOK

MILITARY

MIL-HDBK-780 - Standardized Military Drawings.

(Copies of the specification, standards, bulletin, and handbook required by manufacturers in connection with specific acquisition functions should be obtained from the contracting activity or as directed by the contracting activity.)

2.2 <u>Order of precedence</u>. In the event of a conflict between the text of this drawing and the references cited herein, the text of this drawing shall take precedence.

3. REQUIREMENTS

- 3.1 <u>Item requirements</u>. The individual item requirements for device class M shall be in accordance with 1.2.1 of MIL-STD-883, "Provisions for the use of MIL-STD-883 in conjunction with compliant non-JAN devices" and as specified herein. The individual item requirements for device classes Q and V shall be in accordance with MIL-I-38535 and as specified herein or as modified in the device manufacturer's Quality Management (QM) plan. The modification in the QM plan shall not affect the form, fit, or function as described herein.
- 3.2 <u>Design, construction, and physical dimensions</u>. The design, construction, and physical dimensions shall be as specified in MIL-STD-883 (see 3.1 herein) for device class M and MIL-I-38535 for device classes Q and V herein.
 - 3.2.1 Case outlines. The case outlines shall be in accordance with 1.2.4 herein.
 - 3.2.2 Terminal connections. The terminal connections shall be as specified on figure 1.
 - 3.2.3 Truth tables. The truth tables shall be as specified on figure 2.
 - 3.2.4 Radiation test connections. The radiation test connections shall be as specified in table III herein.
- 3.3 <u>Electrical performance characteristics and postirradiation parameter limits</u>. Unless otherwise specified herein, the electrical performance characteristics and postirradiation parameter limits are as specified in table I and shall apply over the full case operating temperature range.
- 3.4 <u>Electrical test requirements</u>. The electrical test requirements shall be the subgroups specified in table IIA. The electrical tests for each subgroup are defined in table I.
- 3.5 <u>Marking</u>. The part shall be marked with the PIN listed in 1.2 herein. Marking for device class M shall be in accordance with MIL-STD-883 (see 3.1 herein). In addition, the manufacturer's PIN may also be marked as listed in MIL-BUL-103. Marking for device classes Q and V shall be in accordance with MIL-I-38535.
- 3.5.1 <u>Certification/compliance mark</u>. The compliance mark for device class M shall be a "C" as required in MIL-STD-883 (see 3.1 herein). The certification mark for device classes Q and V shall be a "QML" or "Q" as required in MIL-I-38535.
- 3.6 <u>Certificate of compliance</u>. For device class M, a certificate of compliance shall be required from a manufacturer in order to be listed as an approved source of supply in MIL-BUL-103 (see 6.7.2 herein). For device classes Q and V, a certificate of compliance shall be required from a QML-38535 listed manufacturer in order to supply to the requirements of this drawing (see 6.7.1 herein). The certificate of compliance submitted to DESC-EC prior to listing as an approved source of supply for this drawing shall affirm that the manufacturer's product meets, for device class M, the requirements of MIL-STD-883 (see 3.1 herein), or for device classes Q and V, the requirements of MIL-I-38535 and the requirements herein.
- 3.7 <u>Certificate of conformance</u>. A certificate of conformance as required for device class M in MIL-STD-883 (see 3.1 herein) or for device classes Q and V in MIL-I-38535 shall be provided with each lot of microcircuits delivered to this drawing.
- 3.8 <u>Notification of change for device class M</u>. For device class M, notification to DESC-EC of change of product (see 6.2 herein) involving devices acquired to this drawing is required for any change as defined in MIL-STD-973.

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- 3.9 <u>Verification and review for device class M.</u> For device class M, DESC, DESC's agent, and the acquiring activity retain the option to review the manufacturer's facility and applicable required documentation. Offshore documentation shall be made available onshore at the option of the reviewer.
- 3.10 <u>Microcircuit group assignment for device class M.</u> Device class M devices covered by this drawing shall be in microcircuit group number 40 (see MIL-I-38535, appendix A).

4. QUALITY ASSURANCE PROVISIONS

- 4.1 <u>Sampling and inspection</u>. For device class M, sampling and inspection procedures shall be in accordance with MIL-STD-883 (see 3.1 herein). For device classes Q and V, sampling and inspection procedures shall be in accordance with MIL-I-38535 or as modified in the device manufacturer's quality management (QM) plan. The modification in the QM plan shall not affect form, fit, or function as described herein.
- 4.2 <u>Screening</u>. For device class M, screening shall be in accordance with method 5004 of MIL-STD-883, and shall be conducted on all devices prior to quality conformance inspection. For device classes Q and V, screening shall be in accordance with MIL-I-38535, and shall be conducted on all devices prior to qualification and technology conformance inspection.
 - 4.2.1 Additional criteria for device class M.
 - a. Burn-in test, method 1015 of MIL-STD-883.
 - (1) Test condition A, B, C, or D. The test circuit shall be maintained by the manufacturer under document revision level control and shall be made available to the preparing or acquiring activity upon request. The test circuit shall specify the inputs, outputs, biases, and power dissipation, as applicable, in accordance with the intent specified in test method 1015.
 - (2) $T_A = +125^{\circ} C$, minimum.
 - b. Interim and final electrical test parameters shall be as specified in table IIA herein.
 - 4.2.2 Additional criteria for device classes Q and V.
 - a. The burn-in test duration, test condition and test temperature, or approved alternatives shall be as specified in the device manufacturer's QM plan in accordance with MIL-I-38535. The burn-in test circuit shall be maintained under document revision level control of the device manufacturer's Technology Review Board (TRB) in accordance with MIL-I-38535 and shall be made available to the acquiring or preparing activity upon request. The test circuit shall specify the inputs, outputs, biases, and power dissipation, as applicable, in accordance with the intent specified in test method 1015.
 - b. Interim and final electrical test parameters shall be as specified in table IIA herein.
 - c. Additional screening for device class V beyond the requirements of device class Q shall be as specified in appendix B of MIL-I-38535 or as modified in the device manufacturer's quality management (QM) plan.
- 4.3 Qualification inspection for device classes Q and V. Qualification inspection for device classes Q and V shall be in accordance with MIL-I-38535. Inspections to be performed shall be those specified in MIL-I-38535 and herein for groups A, B, C, D, and E inspections (see 4.4.1 through 4.4.4).
- 4.3.1 <u>Electrostatic discharge sensitivity (ESDS) qualification inspection</u>. ESDS testing shall be performed in accordance with MIL-STD-883, method 3015. ESDS testing shall be measured only for initial qualification and after process or design changes which may affect ESDS classification.
- 4.4 <u>Conformance inspection</u>. Quality conformance inspection for device class M shall be in accordance with MIL-STD-883 (see 3.1 herein) and as specified herein. Inspections to be performed for device class M shall be those specified in method 5005 of MIL-STD-883 and herein for groups A, B, C, D, and E inspections (see 4.4.1 through 4.4.4). Technology conformance inspection for classes Q and V shall be in accordance with MIL-I-38535 or as specified in the QM plan including groups A, B, C, D, and E inspections and as specified herein except where option 2 of MIL-I-38535 permits alternate in-line control testing.

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Test	Symbol	Conditions $-55^{\circ}C \le T_{C} \le +125^{\circ}C$ unless otherwise specified	Device	Group A	Lin	Units	
		unless otherwise specified	type	subgroups	Min	Max	
Supply current	I _{DD}	$V_{DD} = 20 \text{ V}, V_{IN} = V_{DD} \text{ or GND}$	All	1		10	μΑ
				2		1000	
		M, D, L, R <u>2</u> /		1		25	
		$V_{DD} = 18 \text{ V}, V_{IN} = V_{DD} \text{ or GND}$		3		10	
		$V_{DD} = 5 \text{ V}, V_{IN} = V_{DD} \text{ or GND } \underline{1}/$		1, 3		5	
				2		150	
		$V_{DD} = 10 \text{ V}, V_{IN} = V_{DD} \text{ or GND } 1/$		1, 3		10	
				2		300	
		$V_{DD} = 15 \text{ V}, V_{IN} = V_{DD} \text{ or GND } 1/$		1, 3		10	
				2		600	
Input leakage current LOW	I _{IL}	$V_{DD} = 20 \text{ V}, V_{IN} = V_{DD} \text{ or GND}$	All	1	-100		nA
LOW				2	-1000		
		$V_{DD} = 18 \text{ V}, V_{IN} = V_{DD} \text{ or GND}$		3	-100		
Input leakage current HIGH	I _{IH}	$V_{DD} = 20 \text{ V}, V_{IN} = V_{DD} \text{ or GND}$	All	1		100	nA
ПІЗП				2		1000	
		$V_{DD} = 18 \text{ V}, V_{IN} = V_{DD} \text{ or GND}$		3		100	
Output voltage, LOW	V _{OL}	V _{DD} = 15 V, no load	All	1, 2, 3		50	mV
		V _{DD} = 5 V, no load <u>1</u> /				50	_
		V _{DD} = 10 V, no load <u>1</u> /				50	
Output voltage, HIGH	VOH	V _{DD} = 15 V, no load <u>3</u> /	All	1, 2, 3	14.95		V
		V _{DD} = 5 V, no load <u>1</u> /			4.95		
		V _{DD} = 10 V, no load <u>1</u> /			9.95		
Low level output current (sink)	loL	$V_{DD} = 5 V$ $V_{O} = 0.4 V$	All	1	0.53		mA
current (Silik)		VO = 0.4 V		2 <u>1</u> /	0.36		
				3 1/	0.64		
		V _{DD} = 10 V V _O = 0.5 V	All	1	1.4		
		vO - 0.5 v		2 <u>1</u> /	0.9		
				3 <u>1</u> /	1.6		
		V _{DD} = 15 V V _O = 1.5 V	All	1	3.5		
		vO - 1.5 v		2 <u>1</u> /	2.4		
				3 <u>1</u> /	4.2		1

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 ${\sf TABLE\ I.\ } \underline{\sf Electrical\ performance\ characteristics} \text{ - Continued.}$

Test Sy	Symbol	Conditions -55° C \leq T _C \leq +125 $^{\circ}$ C	Device	Group A	Lir	nits	Unit
		unless otherwise specified	type	subgroups	Min	Max	
High level output	loн	V _{DD} = 5 V V _{OUT} = 4.6 V	All	1		-0.53	mA
current (source)		VOUT = 4.6 V		2 <u>1</u> /		-0.36	
				3 <u>1</u> /		-0.64	
		V _{DD} = 5 V V _{OUT} = 2.5 V	All	1		-1.8	
		001		2 <u>1</u> /		-1.15	
				3 <u>1</u> /		-2.0	
		V _{DD} = 10 V V _{OUT} = 9.5 V	All	1		-1.4	
		1001 = 0.0 1		2 <u>1</u> /		-0.9	
				3 <u>1</u> /		-1.6	
		V _{DD} = 15 V V _{OUT} = 13.5 V	All	1		-3.5	2.4
		1001 = 16.6 1		2 <u>1</u> /		-2.4	
			_	3 <u>1</u> /		-4.2	
Input voltage	VIL	$V_{DD} = 5 \text{ V}$ $V_{OH} > 4.5 \text{ V}, V_{OL} < 0.5 \text{ V}$	All	1, 2, 3		1.5	V
		V _{DD} = 10 V V _{OH} > 9.0 V, V _{OL} < 1.0 V <u>1</u> /		1, 2, 3		3	
		V _{DD} = 15 V V _{OH} > 13.5 V, V _{OL} < 1.5 V		1, 2, 3		4	
	V _{IH}	V _{DD} = 5 V V _{OH} > 4.5 V, V _{OL} < 0.5 V	All	1, 2, 3	3.5		
		V _{DD} = 10 V V _{OH} > 9.0 V, V _{OL} < 1.0 V <u>1</u> /		1, 2, 3	7		
		V _{DD} = 15 V V _{OH} > 13.5 V, V _{OL} < 1.5 V		1, 2, 3	11		
N threshold voltage	V _{NTH}	V _{DD} = 10 V, I _{SS} = -10 μA	All	1	-0.7	-2.8	V
		M, D, L, R <u>2</u> /			-0.2	-2.8	
N threshold voltage, delta	ΔV _{NTH}	$V_{DD} = 10 \text{ V, I}_{SS} = -10 \mu\text{A}, M, D, L, R \frac{2}{2}$	All	1		±1.0	
P threshold voltage	V _{PTH}	$V_{SS} = 0.0 \text{ V, } I_{DD} = 10 \mu\text{A}$	All	1	0.7	2.8	
		M, D, L, R <u>2</u> /		1	0.2	2.8	
P threshold voltage, delta	ΔV _{PTH}	V _{SS} = 0.0 V, I _{DD} = 10 μA M, D, L, R 2/	All	1		±1.0	

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		TABLE I. Electrical pe						
Test	Symbol	Cond -55°C ≤ T _C unless otherv	iuons <u><</u> +125°C vise specified	Device type	Group A subgroups	Limits		Unit
		unicos otriciv	noc opecinica	type	Subgroups	Min	Max	
Functional tests		$V_{DD} = 2.8 \text{ V}, V_{IN} = V_{IN}$	DD or GND	All	7	VÕH	V _{OL} < V _{DD} /2	V
		$V_{DD} = 20 \text{ V}, V_{IN} = V$	$V_{DD} = 20 \text{ V}, V_{IN} = V_{DD} \text{ or GND}$ $V_{DD} = 18 \text{ V}, V_{IN} = V_{DD} \text{ or GND}$ M, D, L, R $\underline{2}/$ $V_{DD} = 3.0 \text{ V}, V_{IN} = V_{DD} \text{ or GND}$		7	V _{DD} /2	VDD/2	
		$V_{DD} = 18 \text{ V}, V_{IN} = V$			8A			
		M, D,			7			
		$V_{DD} = 3.0 \text{ V}, V_{IN} = V_{IN}$			8B			
		M, D,	L, R 2/	All	7			
Input capacitance	C _{IN}	Any input, See 4.4.10	: 1/	All	4		7.5	pF
Tri-state output leakage current (low)	lozL	$V_{IN} = V_{DD}$ or GND $V_{OUT} = 0$ V	V _{DD} = 20V	All	1	-0.4		μΑ
current (low)		VOUT - 0 V			2	-12		
		V _{DD} = 18V		3	-0.4			
Tri-state output leakage current high	lozh	$V_{IN} = V_{DD}$ or GND $V_{OUT} = 0$ V	V _{DD} = 20V	All	1		0.4	μΑ
current night		VOUT - 0 V			2		12	
		V _{DD} = 18V			3		0.4	
Propagation delay time,	^t PHL [,]	$V_{A}DD = 5 \text{ V}, V_{IN} = V_{D}$	D or GND	All	9		440	ns
clock to Q	'PLH	<u></u>			10, 11		594	
		M, D, L, R 2/			9		594	
		V _{DD} = 10 V <u>1</u> /, <u>4</u> /			9		200	
		V _{DD} = 15 V <u>1</u> /, <u>4</u> /			9		140	
Propagation delay time, reset to Q	^t PHL	$V_{DD} = 5 \text{ V}, V_{IN} = V_{D}$	D or GND	02	9		460	ns
reset to Q					10, 11		621	
		M, D,	L, R <u>2</u> /		9		621	
		V _{DD} = 10 V <u>1</u> /, <u>4</u> /			9		180	
		V _{DD} = 15 V <u>1</u> /, <u>4</u> /			9		130	
Propagation delay time, 3-state	^t PZH,	$V_{DD} = 5 \text{ V}, V_{IN} = V_{D}$	D or GND	01	9		160	ns
o-state	^t PZH, ^t PZL, ^t PLZ				10, 11		216	
		M, D,	L, R <u>2</u> /		9		216	
		V _{DD} = 10 V <u>1</u> /, <u>5</u> / V _{DD} = 15 V <u>1</u> /, <u>5</u> /			9		70	
					9		50	
t _{PHZ} V _P		$V_{DD} = 5 \text{ V}, V_{IN} = V_{D}$	D or GND		9		90	
					10, 11		122	
		M, D,	L, R 2/		9		122	
		V _{DD} = 10 V <u>1</u> /, <u>5</u> /			9		50	
		V _{DD} = 15 V <u>1</u> /, <u>5</u> /			9		40	

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		TABLE I. <u>Electrical performance chara</u>	cteristics - Cor	ntinued.			
Test	Symbol	Conditions $-55^{\circ} C \le T_{C} \le +125^{\circ} C$ unless otherwise specified	Device	Group A	Lir	Limits	
		unless otherwise specified	type	subgroups	Min	Max]
Transition time t _{THL} , t _{TLH}	t _{THL} ,	$V_{DD} = 5 \text{ V}, V_{IN} = V_{DD} \text{ or GND}$	All	9		200	ns
	LTLH	4/		10, 11		270	
		V _{DD} = 10 V <u>1</u> /, <u>4</u> /		9		100	
		V _{DD} = 15 V <u>1</u> /, <u>4</u> /		9		80	
Maximum clock input FCL frequency	FCL	$V_{DD} = 5 \text{ V}, V_{IN} = V_{DD} \text{ or GND}$	All	9	3		MHz
		4/		10, 11	2.22		
Minimum data setup time, D0, D3, SRIN, SLIN to clock	V _{DD} = 5 V <u>1</u> /, <u>4</u> /	All	9		100	ns	
		V _{DD} = 10 V <u>1</u> /, <u>4</u> /		9		70	
		V _{DD} = 15 V <u>1</u> /, <u>4</u> /		9		50	
Minimum data hold time, D0, D3, SRIN, SLIN to clock	t _H	V _{DD} = 5 V <u>1</u> /, <u>4</u> /	All	9		0	ns
		V _{DD} = 10 V <u>1</u> /, <u>4</u> /		9		0	-
		V _{DD} = 15 V <u>1</u> /, <u>4</u> /		9		0	
Minimum clock pulse	t _W	V _{DD} = 5 V 1/, 4/	All	9		180	ns
width		V _{DD} = 10 V <u>1</u> /, <u>4</u> /		9		80	
		V _{DD} = 15 V <u>1</u> /, <u>4</u> /		9		50	
Maximum clock rise and	t _{RCL} ,	V _{DD} = 5 V <u>1</u> /, <u>4</u> /	All	9	3		μs
fall time	^t FCL	V _{DD} = 10 V 1/, 4/		9	6		-
		V _{DD} = 15 V 1/, 4/		9	8		1
Minimum data setup time,	t _S	V _{DD} = 5 V <u>1</u> /, <u>4</u> /	All	9		400	ns
select 1, select 0 to clock		V _{DD} = 10 V <u>1</u> /, <u>4</u> /		9		220	1
		V _{DD} = 15 V <u>1</u> /, <u>4</u> /		9		130	1
Minimum data hold time,	t _H	V _{DD} = 5 V 1/, 4/	All	9		0	ns
select 1, select 0 to clock		V _{DD} = 10 V <u>1</u> /, <u>4</u> /		9		0	
		V _{DD} = 15 V <u>1</u> /, <u>4</u> /		9		0	1
Minimum reset pulse	t _W	$V_{DD} = 5 V 1/, 4/$	02	9		300	ns
width		V 10 V 1/ 4/		a		200	1

^{1/} These tests are controlled via design or process and are not directly tested. These parameters are characterized on initial design release and upon design changes which affect these characteristics.

 $V_{DD} = 15 \text{ V } \underline{1}/, \underline{4}/$

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9

200

140

^{2/} Devices supplied to this drawing will meet all levels M, D, L, R of irradiation. However, this device is only tested at the 'R' level. When performing post irradiation electrical measurements for any RHA level, $T_A = +25^{\circ}$ C. 3/ For accuracy, voltage is measured differentially to V_{DD} . Limit is 0.050 V Max. 4/ $C_L = 50$ pF, $R_L = 200$ k Ω , input t_R , $t_F < 20$ ns. 5/ $C_L = 50$ pF, $R_L = 1$ k Ω , input t_R , $t_F < 20$ ns.

Device type	01	02		
Case outlines	E and X			
Terminal number	Terminal symbol			
1 2 3 4 5 6 7 8 9 10 11 12 13 14 15 16	OUTPUT ENABLE SHIFT RIGHT IN D0 D1 D2 D3 SHIFT LEVEL IN VSS SELECT 0 SELECT 1 CLOCK Q3 Q2 Q1 Q0 VDD	RESET SHIFT RIGHT IN D0 D1 D2 D3 SHIFT LEVEL IN VS SELECT 0 SELECT 1 CLOCK Q3 Q2 Q1 Q0 VDD		

FIGURE 1. <u>Terminal connections</u>.

Device type 01

CLOCK*	MODE SELECT		OUTPUT ENABLE	ACTION
	S0	S1		
/	0	0	1	Reset
_/	1	0	1	Shift right (Q0 toward Q3)
_/	0	1	1	Shift left (Q3 toward Q0)
_/	1	1	1	Parallel load
Х	X	X	0	Operations occur as shown above, but outputs assume high impedance

Device type 02

CLOCK*	MODE SELECT		RESET	ACTION
	S0	S1		
Х	0	0	1	no change
_/	1	0	1	Shift right (Q0 toward Q3)
_/	0	1	1	Shift left (Q3 toward Q0)
/	1	1	1	Parallel load
Х	Х	Х	0	Reset

NOTES: Logic 0 = low Logic 1 = high Z = high impedance X = don't care

* Level change

Figure 2. Truth tables.

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- 4.4.1 Group A inspection.
 - a. Tests shall be as specified in table IIA herein.
 - b. For device class M, subgroups 7 and 8 tests shall be sufficient to verify the truth table in figure 2 herein. For device classes Q and V, subgroups 7 and 8 shall include verifying the functionality of the device.
 - c. Subgroup 4 (C_{IN} measurement) shall be measured only for the initial qualification and after process or design changes which may affect capacitance. C_{IN} shall be measured between the designated terminal and GND at a frequency of 1 MHz. Tests shall be sufficient to validate the limits defined in table I herein.
- 4.4.2 Group C inspection. The group C inspection end-point electrical parameters shall be as specified in table IIA herein.
- 4.4.2.1 Additional criteria for device class M. Steady-state life test conditions, method 1005 of MIL-STD-883:
 - a. Test condition A, B, C or D. The test circuit shall be maintained by the manufacturer under document revision level control and shall be made available to the preparing or acquiring activity upon request. The test circuit shall specify the inputs, outputs, biases, and power dissipation, as applicable, in accordance with the intent specified in test method 1005.
 - b. $T_A = +125^{\circ} C$, minimum.
 - c. Test duration: 1,000 hours, except as permitted by method 1005 of MIL-STD-883.
- 4.4.2.2 Additional criteria for device classes Q and V. The steady-state life test duration, test condition and test temperature, or approved alternatives shall be as specified in the device manufacturer's QM plan in accordance with MIL-I-38535. The test circuit shall be maintained under document revision level control by the device manufacturer's TRB, in accordance with MIL-I-38535, and shall be made available to the acquiring or preparing activity upon request. The test circuit shall specify the inputs, outputs, biases, and power dissipation, as applicable, in accordance with the intent specified in test method 1005.
 - 4.4.3 Group D inspection. The group D inspection end-point electrical parameters shall be as specified in table IIA herein.
- 4.4.4 <u>Group E inspection</u>. Group E inspection is required only for parts intended to be marked as radiation hardness assured (see 3.5 herein). RHA levels for device classes M, Q and V shall be as specified in MIL-I-38535. End-point electrical parameters shall be as specified in table IIA herein.
- 4.4.4.1 <u>Total dose irradiation testing</u>. Total dose irradiation testing shall be performed in accordance with MIL-STD-883 method 1019 and as specified herein.
- 4.4.4.1.1 <u>Accelerated aging test</u>. Accelerated aging tests shall be performed on all devices requiring a RHA level greater than 5k rads(Si). The post-anneal end-point electrical parameter limits shall be as specified in table I herein and shall be the pre-irradiation end-point electrical parameter limit at +25°C ±5°C. Testing shall be performed at initial qualification and after any design or process changes which may affect the RHA response of the device.
- 4.4.4.2 <u>Dose rate induced latchup testing</u>. Dose rate induced latchup testing shall be performed in accordance with test method 1020 of MIL-STD-883 and as specified herein (see 1.4 herein). Tests shall be performed on devices, SEC, or approved test structures at technology qualification and after any design or process changes which may effect the RHA capability of the process.
- 4.4.4.3 <u>Dose rate upset testing</u>. Dose rate upset testing shall be performed in accordance with test method 1021 of MIL-STD-883 and herein (see 1.4 herein).
 - a. Transient dose rate upset testing shall be performed at initial qualification and after any design or process changes which may effect the RHA performance of the devices. Test 10 devices with 0 defects unless otherwise specified.
 - Transient dose rate upset testing for class Q and V devices shall be performed as specified by a TRB approved radiation hardness assurance plan and MIL-I-38535.

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TABLE IIA. Electrical test requirements.

Test requirements	Subgroups (in accordance with MIL-STD-883, TM 5005, table I)	Subgroups (in accordance with MIL-I-38535, table III)	
	Device class M	Device class Q	Device class V
Interim electrical parameters (see 4.2)	1,7,9	1,7,9	1,7,9
Final electrical parameters (see 4.2)	1,2,3,7,8,9,10,11 <u>1</u> /	1,2,3,7,8,9,10,11 <u>1</u> /	1,2,3,7,8,9,10,11 <u>2</u> / <u>3</u> /
Group A test requirements (see 4.4)	1,2,3,4,7,8,9,10,11	1,2,3,4,7,8,9,10,11	1,2,3,4,7,8,9,10,11
Group C end-point electrical parameters (see 4.4)	1,2,3,7,8,9,10,11	1,2,3,7,8,9,10,11	1,2,3,7,8,9,10,11 <u>3</u> /
Group D end-point electrical parameters (see 4.4)	1,7,9	1,7,9	1,7,9
Group E end-point electrical parameters (see 4.4)	1,7,9	1,7,9	1,7,9

- 1/ PDA applies to subgroup 1 and 7.
- 2/ PDA applies to subgroups 1, 7 and 9 and deltas.
- 3/ Delta limits as specified in table IIB shall be required where specified, and the delta limits shall be completed with reference to the zero hour electrical parameters (see Table I)

Table IIB. Burn-in and operating life test Delta parameters (+25°C)

Parameter	Symbol	Delta Limits
Supply current	I _{DD}	±1.0 μA
Output current (sink) V _{DD} = 5.0 V	loL	±20%
Output current (source) VDD = 5.0 V, VOLIT = 4.6 V	loн	±20%

- 4.4.4.4 <u>Single event phenomena (SEP)</u>. SEP testing shall be required on class V devices (see 1.4 herein). SEP testing shall be performed on a technology process on the Standard Evaluation Circuit (SEC) or alternate SEP test vehicle as approved by the qualifying activity at initial qualification and after any design or process changes which may affect the upset or latchup characteristics. The recommended test conditions for SEP are as follows:
 - a. The ion beam angle of incidence shall be between normal to the die surface and 60° to the normal, inclusive (i.e. 0° ≤ angle ≤ 60°). No shadowing of the ion beam due to fixturing or package related effects is allowed.
 - b. The fluence shall be ≥ 100 errors or $\ge 10^6$ ions/cm².
 - c. The flux shall be between 10² and 10⁵ ions/cm²/s. The cross-section shall be verified to be flux independent by measuring the cross-section at two flux rates which differ by at least an order of magnitude.
 - d. The particle range shall be ≥ 20 microns in silicon.
 - e. The test temperature shall be +25° C and the maximum rated operating temperature $\pm 10^{\circ}\,\text{C}.$
 - f. Bias conditions shall be defined by the manufacturer for latchup measurements.
 - g. Test four devices with zero failures.

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Table III. <u>Irradiation test connections</u>. <u>1</u>/

Open	Ground	V _{DD} = 10 V ±0.5 V
12,13,14,15	8	1,2,3,4,5,6,7,9,10,11,16

- $\underline{1}$ / Each pin except V_{DD} and GND will have a series resistor of 47K Ω ±5%, for irradiation testing.
 - 4.5 Methods of inspection. Methods of inspection shall be as specified as follows:
- 4.5.1 <u>Voltage and current</u>. Unless otherwise specified, all voltages given are referenced to the microcircuit GND terminal. Currents given are conventional current and positive when flowing into the referenced terminal.
 - 5. PACKAGING
- 5.1 <u>Packaging requirements</u>. The requirements for packaging shall be in accordance with MIL-STD-883 (see 3.1 herein) for device class M and MIL-I-38535 for device classes Q and V.
 - 6. NOTES
- 6.1 <u>Intended use</u>. Microcircuits conforming to this drawing are intended for use for Government microcircuit applications (original equipment), design applications, and logistics purposes.
- 6.1.1 <u>Replaceability</u>. Microcircuits covered by this drawing will replace the same generic device covered by a contractor-prepared specification or drawing.
 - 6.1.2 Substitutability. Device class Q devices will replace device class M devices.
- 6.2 <u>Configuration control of SMD's</u>. All proposed changes to existing SMD's will be coordinated with the users of record for the individual documents. This coordination will be accomplished in accordance with MIL-STD-973 using DD Form 1692, Engineering Change Proposal.
- 6.3 <u>Record of users</u>. Military and industrial users shall inform Defense Electronics Supply Center when a system application requires configuration control and which SMD's are applicable to that system. DESC will maintain a record of users and this list will be used for coordination and distribution of changes to the drawings. Users of drawings covering microelectronic devices (FSC 5962) should contact DESC-EC, telephone (513) 296-6047.
- 6.4 <u>Comments</u>. Comments on this drawing should be directed to DESC-EC, Dayton, Ohio 45444-5270, or telephone (513) 296-5377.
- 6.5 <u>Abbreviations, symbols, and definitions</u>. The abbreviations, symbols, and definitions used herein are defined in MIL-I-38535 and MIL-STD-1331.

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6.6 One part - one part number system. The one part - one part number system described below has been developed to allow for transitions between identical generic devices covered by the three major microcircuit requirements documents (MIL-H-38534, MIL-I-38535, and 1.2.1 of MIL-STD-883) without the necessity for the generation of unique PIN's. The three military requirements documents represent different class levels, and previously when a device manufacturer upgraded military product from one class level to another, the benefits of the upgraded product were unavailable to the Original Equipment Manufacturer (OEM), that was contractually locked into the original unique PIN. By establishing a one part number system covering all three documents, the OEM can acquire to the highest class level available for a given generic device to meet system needs without modifying the original contract parts selection criteria.

Military documentation format	Example PIN under new system	Manufacturing source listing	Document <u>listing</u>
New MIL-H-38534 Standard Microcircuit Drawings	5962-XXXXXZZ(H or K)YY	QML-38534	MIL-BUL-103
New MIL-I-38535 Standard Microcircuit Drawings	5962-XXXXXZZ(Q or V)YY	QML-38535	MIL-BUL-103
New 1.2.1 of MIL-STD-883 Standard Microcircuit Drawings	5962-XXXXXZZ(M)YY	MIL-BUL-103	MIL-BUL-103

- 6.7 Sources of supply.
- 6.7.1 <u>Sources of supply for device classes Q and V</u>. Sources of supply for device classes Q and V are listed in QML-38535. The vendors listed in QML-38535 have submitted a certificate of compliance (see 3.6 herein) to DESC-EC and have agreed to this drawing.
- 6.7.2 Approved sources of supply for device class M. Approved sources of supply for class M are listed in MIL-BUL-103. The vendors listed in MIL-BUL-103 have agreed to this drawing and a certificate of compliance (see 3.6 herein) has been submitted to and accepted by DESC-EC.
- 6.8 <u>Additional information</u>. A copy of the following additional data shall be maintained and available from the device manufacturer:
 - a. RHA upset levels.
 - b. Test conditions (SEP).
 - c. Number of upsets (SEP).
 - d. Number of transients (SEP).
 - e. Occurrence of latchup (SEP).

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STANDARD MICROCIRCUIT DRAWING SOURCE APPROVAL BULLETIN

DATE: 95-12-06

Approved sources of supply for SMD 5962-96601 are listed below for immediate acquisition only and shall be added to MIL-BUL-103 and QML-38535 during the next revision. MIL-BUL-103 and QML-38535 will be revised to include the addition or deletion of sources. The vendors listed below have agreed to this drawing and a certificate of compliance has been submitted to and accepted by DESC-EC. This bulletin is superseded by the next dated revision of MIL-BUL-103 and QML-38535.

Standard microcircuit drawing PIN	Vendor CAGE number	Vendor similar PIN <u>1</u> /
5962R9660101VEC	34371	CD40104BDMSR
5962R9660101VXC	34371	CD40104BKMSR
5962R9660102VEC	34371	CD40194BDMSR
5962R9660102VXC	34371	CD40194BKMSR

1/ Caution. Do not use this number for item acquisition. Items acquired to this number may not satisfy the performance requirements of this drawing.

Vendor CAGEVendor namenumberand address

34371 Harris Semiconductor

P.O. Box 883

Melbourne, FL 32902-0883

The information contained herein is disseminated for convenience only and the Government assumes no liability whatsoever for any inaccuracies in this information bulletin.